

Notice of References Cited

Application/Control No.

10/518,194

Applicant(s)/Patent Under

Reexamination

NOMURA ET AL.

Examiner

EDNA WONG

Art Unit

1795

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*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
A	US-			
B	US-			
C	US-			
D	US-			
E	US-			
F	US-			
G	US-			
H	US-			
I	US-			
J	US-			
K	US-			
L	US-			
M	US-			

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*	U Masui et al., "Warp Control in Strip Processing Plant", ISIJ International, Vol. 31 (no month, 1991), No. 3, pp. 262-267.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a))
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